Growth of Cr-doped GaN Nanowires

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Cr-Doped GaN nanowires were fabricated using a chemical vapour deposition method. The structures, morphologies and compositions of the products have been characterized by powder X-ray diffraction, transmission electron microscopy, selected area electron diffraction and energy dispersive X-ray analysis. Results revealed that the obtained nanowires are single-crystal GaN with hexagonal wurtzite structure. TEM images show two different morphologies, the bent and the very straight nanostructures. The optical property of Cr-doped GaN was observed in the photoluminescence spectra, which shows the as-prepared product emits a strong UV light emission at 395 nm and a yellow luminescence at 580 nm ($\lambda_{\text{ex}} = 325$ nm).

Key Words: Nanoparticles, Chemical vapour deposition, Crystal growth.

INTRODUCTION

Recently, there has been growing interest in the fabrication of GaN nanowires for their potential applications in optoelectronic and nanoscale electronic devices which take advantage of the unique high-aspect ratio structure of nanowires¹⁻⁴. A variety of techniques have been utilized to synthesize GaN nanowires including chemical vapour deposition (CVD), hydride vapour-phase epitaxy, metal-organic chemical vapour deposition (MOCVD) and template-based growth method⁵⁻⁸. Among these methods, chemical vapour deposition process in a horizontal furnace reactor is of particular interest due to the low cost of equipment and the simplicity of the experimental procedure. Moreover, GaN materials doped with transition metals, such as Mn, V, Ni and so on, have attracted much attention due to their peculiar optical electrical or magnetic properties⁹⁻¹⁴. In this letter, Cr-doped GaN nanowires were successfully synthesized using catalyst-assisted chemical vapour deposition method by evaporating Ga₂O₃ powder under ammonia. The growth method allows a continuous synthesis and produces high purity GaN nanowires. The effect of Cr-doping on the optical and structural properties of GaN nanowires was investigated.

EXPERIMENTAL

Preparation of GaN nanowires: A quartz boat holding both the substrate and 0.5 g Ga₂O₃ powder (99.99 %) was placed inside a quartz tube in a horizontal tube furnace. Silicon substrates coated with Ni(NO₃)₂ were placed downstream of the Ga₂O₃ powder. The distance between the substrate and

Ga₂O₃ was 7 mm. Then, the flowing Ar (99.999 %) gas was introduced into the tube to flush out the residual air for 5 min and then NH₃ was flowed into the tube with a flow rate of 3 L/h for 8 h at 900 °C. After ammoniated, the flowing Ar (99.999 %) gas was introduced into the tube to flush out the residual NH₃ for 5 min. After reaction, a light-yellow layer was found on the substrate surface.

Preparation of Cr-doped GaN nanowires: GaN nanowires were grown by chemical vapour deposition at 900 °C. A Ga₂O₃ was used as the Ga source, NH₃ as the N source and CrCl₃·6H₂O as the Cr dopant source. Si(100) was used for substrate. Ni(NO₃)₂ was employed as catalyst, respectively. Prior to the growth of GaN nanowires, drying was performed in Ar ambient for 0.5 h. Then, the growth temperature was adjusted to 900 °C in NH₃ ambient and GaN nanowires were grown for 3 h. After terminating the growth, the sample was cooled down in NH₃ ambient from the growth temperature to 50 °C.

X-Ray powder diffraction patterns were carried out on a D/max-2500/PC X-ray diffractometer with CuK_α radiation ($\lambda = 0.15418$ nm) to study the phases in presence. The morphologies of samples were characterized by transmission electron microscopy (TEM) using a JEM-2010 transmission electron microscope with EDS and a scanning electron microscope (SEM; XL30 ESEM FEG). Transmission electron diffraction (TED) was used to investigate the phase structure of the obtained powder. Room-temperature photoluminescence measurement of dry powder was recorded with a FL3-11 fluorescence spectrophotometer using an excitation wavelength of 325 nm and a slitwidth of 2 nm.

RESULTS AND DISCUSSION

Fig. 1 shows the XRD patterns of the undoped and Cr-doped GaN nanowires grown on the silicon substrate. The five peaks (100), (002), (101), (110) and (103) of undoped GaN nanowires are located at 32.6, 34.7, 36.9, 58.0 and 63.7°, respectively, demonstrating that the reflections can be indexed to the hexagonal wurtzite GaN phase with the lattice constants $a = 0.318$ nm and $c = 0.517$ nm. Compared with undoped GaN, the d-space of (100) planes of the Cr-doped GaN increase from 0.274–0.280 nm. Because the ionic radius of Cr and Ga are 0.69 and 0.62 Å, respectively, the doping of Cr induces the increase of the crystal constant of GaN nanowires. Both the spectra show that the peak (101) has the highest intensity. The intensity of the peak depends on the number of nanowires grown along the lattice orientation in the nanostructured films. The strongest (101) peak indicates that the maximum nanowires grow along [101] orientation. Moreover, no other peaks of impurities appears in the spectra, indicating the predominant single wurtzite GaN phase of the deposit and the sharp diffraction peaks also reveal that the GaN nanowires possess good crystalline quality. There is only one peak of the Si at $2\theta = 69.10^\circ$ with high intensity in this plot.

Fig. 1. X-Ray diffraction patterns of (a) undoped GaN and (b) Cr-doped GaN nanowires

The typical SEM images of the undoped GaN nanowires are shown in Fig. 2. Analysis of SEM micrographs indicates clearly that the sample contains a large number of wire-like nanostructures with typical lengths in the range of several tens to several hundreds of micrometers. These nanowires intertwine with each other and homogeneously distributed over the whole surface of Si substrate. The range of the diameter of as-grown nanowires spans from 50–100 nm and small variation in diameter could be found along an individual nanowire as shown in Fig. 2(b).

Further observation reveals that there are solid particles located at the end of the nanowires. Energy dispersive X-ray spectrum (Fig. 2c) which was taken from the circle marked part in Fig. 2(b) shows that there are Ga, N and Ni at the tip and the presence of small amount of Ni confirms that the solid particles are actually metal nickel. It was concluded that the GaN nanowires were grown *via* the VLS mechanism by employing an Ni as a metal catalyst to initiate the seed of the

Fig. 2. FESEM images and EDX spectra of GaN nanowires. (a) Typical SEM image of GaN nanowires at low magnification; (b) Magnified image of GaN nanowires at local part; (c) The EDX spectrum taken from the top of GaN nanowires; (d) the EDX spectrum taken from GaN nanowires; (e) The TEM image of a straight nanowire; (f) The corresponding HRTEM image of the nanowires. Inset: the SAED image of the GaN nanowires

GaN nanowires. Several EDS measurements taken from other parts of nanowire were used to estimate the stoichiometry of the wires. From the spectra as shown in Fig. 2(d), it can be seen that the nanowires are composed mainly of N atom and Ga atom, (Cu peaks are due to the copper grid used for TEM measurements). The A % data of N atom and Ga atom is 49.42 and 50.58 %, which make stoichiometric GaN clearly. Fig. 2(e) shows a representative TEM image of a free-standing straight nanowire, which has diameter of *ca.* 53 nm and is *ca.* 60 μ m long. According to the observation of TEM, the estimated yield of the straight nanowires is less than 5 %. High-resolution TEM (HRTEM) was carried out to further understand the structural properties of GaN nanowires. Fig. 2(f) shows the HRTEM image of an individual GaN nanowire with a diameter of *ca.* 70 nm. The well-spaced lattice fringe in the image indicate the single crystal structure of GaN nanowires with high crystalline quality but with less dislocations and defects. The measured spacing between adjacent lattice planes is 0.273 nm, corresponding to (100) plane of as-prepared GaN, indicating that the nanowire preferably grew along the [100] direction. Further evidence for the formation of single-crystalline nanowires could be found in selected area electron diffraction pattern. The insert in the upper-right-hand corner is the selected area electron diffraction pattern of the nanowire, which can be indexed to the reflection of single crystalline hexagonal wurtzite GaN with the growth direction parallel to the [100] direction of hexagonal unit cell.

The morphologies of Cr-doped GaN samples grown on the surface of Si substrate were investigated by TEM. The resulting sample shows two different morphologies, the bent and the very straight nanostructures. Fig. 3(a) is the typical low-magnification TEM image of the bent Cr-doped GaN nanowires. The nanowires were apt to grow with less bent structure, even very straight Cr-doped GaN nanowires were synthesized with almost uniform diameter of *ca.* 50 nm as shown in Fig. 3(b). According to the observation of TEM, the estimated yield of the straight nanowires reaches to *ca.* 50 %. Fig. 3(c) show a representative TEM image of a free-standing nanowire, which is *ca.* 10 μ m long.

Fig. 3. TEM images of Cr-doped GaN nanowires. (a) TEM image of bent Cr-doped GaN nanowires; (b) TEM image of straight Cr-doped GaN nanowires; (c) TEM image of an individual straight Cr-doped GaN nanowires; (d) EDS spectrum of Cr-doped GaN nanowire

The nanowire possess fairly straight morphology and also have a smooth surface without any particles. The representative EDS spectrum (Fig. 3d) taken from several parts of the straight nanowires shows that the nanowire is composed pre-dominantly of Ga-48 at. and N-49 at. % and a small amount of Cr-3 at. %, suggesting the GaN nanowires are doped with Cr.

A further investigation on the microstructure of the Cr-doped GaN nanowires was performed by HRTEM. The HRTEM image as shown in Fig. 4a was taken from the the blue circle marked part in Fig. 3(c) and clearly shows the lattice fringes which are consistent throughout the crystal. It also reveals that the examined region is free from dislocation and stacking faults, whereas the surface of the wire terminated with thin (*ca.* 0.5 nm) and smooth amorphous layers. Higher resolution TEM image as shown in Fig. 4b present the clear crystal lattice of nanowires. The crystal plane spacing is *ca.* 0.279 nm, which is larger than that of (100) crystal plane spacing (0.274 nm) of hexagonal GaN. Cr doping slightly changes the lattice constant of GaN, which is in accordance with XRD result. The corresponding fast Fourier transform (FFT) pattern, shown in the inset of Fig. 4b, reveal that the nanowires is high quality single-crystal in nature. The spots on the pattern can be attributed to the [100] zone axis of hexagonal GaN. This indicates that the Cr-doped GaN nanowires grew along the [100] direction.

Fig. 4. HRTEM images of Cr-doped GaN nanowires. (a) HRTEM image taken from the edge part of straight Cr-doped GaN nanowires; (c) HRTEM image taken from the blue circle marked part in Fig. 4c. The inset shows the corresponding fast Fourier transform (FFT) image

The optical properties of nanowires are important in understanding the quality of the materials and the potential application in optoelectronics. PL spectrum of GaN product presented in Fig. 5(a), which was detected with He-Cd laser as the excitation source (with a wavelength of 325 nm) at room temperature (22 °C). A strong UV light emission peak at 388 nm is observed as shown in Fig. 5(a), which corresponds to the GaN near band-edge emission. Because GaN nanowires are too large for quantum confinement effects and the diameter of the thinnest nanowire is much larger than the Bohr exciton radius (11 nm) of GaN, the PL emission has no blue shift but redshift from the bandgap emission compared with bulk GaN¹⁵. The optical properties of Cr-doped GaN nanowires are also shown in Fig. 5(b). Three emission peaks at 395, 532 and 580 nm are observed. The 395 nm emission should result from GaN band-edge emission and the small peak at 532 nm may attributed to deep-level emission¹⁶. The yellow emission at 580 nm might be ascribed to intrinsic point defects, such as Ga

vacancies, to impurities or to complexes of intrinsic defects and impurities¹⁷. These defects would induce new energy levels in the band gap. Compared with the bulk GaN, both of the luminescence peaks of the undoped GaN and Cr-doped GaN nanowires produced a slight red shift. In the general consideration for photoluminescence spectra of one-dimensional structure, the red shift of the photoluminescence peaks is mainly caused by occasional defects such as point defects and stack faults. The as-synthesized GaN nanowires have good optical properties, which supply the advantage for the applications in photoelectron devices. However, further work is needed to investigate the photoluminescence mechanism of the GaN nanowires.

Conclusion

The Cr-doped GaN nanowires were successfully fabricated by chemical vapour deposition. The diameter of GaN nanowire was *ca.* 50 nm and their length was about several hundreds of micrometers. The PL measurement demonstrated that the undoped GaN nanowire has a strong emission peak at 388 nm. The typical emissions related to Cr-doped GaN at 395 nm were also observed.

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Fig. 5. Photoluminescence spectrum of the (a) undoped and (b) Cr-doped GaN nanowire